



High Precision Measurement Product Catalog

- TS-P Series Laser Displacement Sensors
- TS-C Series Spectral Confocal Displacement Sensors
- TS-I Series Interferometric Thickness Sensors

C Company Profile

About US

Suzhou TronSight Intelligent Technology Co., Ltd. focuses on the research, development, production, and sales of precision inspection systems and sensors, established by a highly educated team in Wu Zhong District, Suzhou. The company adheres to the principles of technology-driven R&D, application demand orientation, and customer service priority, aiming to become an independent brand in the field of precision measurement.

Since its establishment, the company has received numerous honors and funding, independently developed multiple high-precision sensor products, and serves various industries. The company values intellectual property rights and quality certification, dedicated to technological innovation to support the development of China's intelligent manufacturing.



Honors



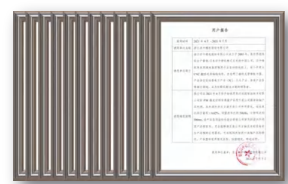
Suzhou Innovation and Entrepreneurship Leading Talent



High-tech Enterprise Certificate



Innovative and Entrepreneurial Leading Talent of Eastern Wu



Leading companies report



CE & RoHS



Dozens of patent certificates



ISO Quality Management System Certificate



2023 Chinese Invisible unicorns

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Spectral Confocal Displacement Sensor

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Interferometric thickness sensor

Principle
Model/Application
Parameters
Dimension Figure



| *TS-P Series* |

Laser Triangulation Displacement Sensor

0.02
 μm

Ultra-high
Repeatability

± 0.02
% of F.S

Ultra-high
Linearity

Max **160**
kHz

Ultra-fast
Sampling Rate

Ethernet
RS-485
Analog Output

Simple Interface
Configuration



◆ Why choose TronSight?



Full-frequency
Industrial IO



Controller-Free



Ultra-fast Sampling Rate



Ultra-long
Measuring Distance



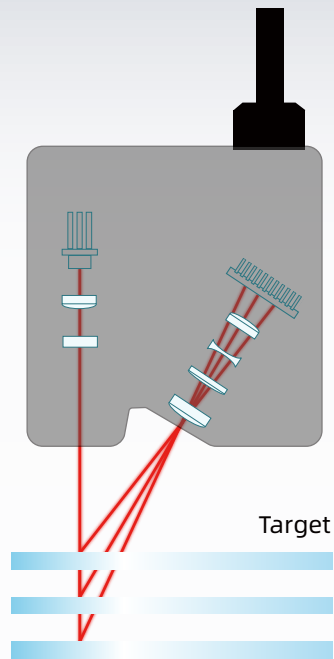
Self-Developed



Specular/Diffuse
Reflection



Measurement Principle

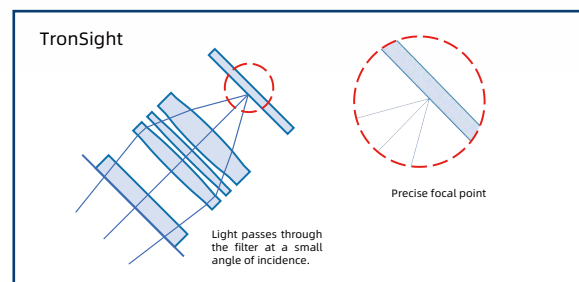
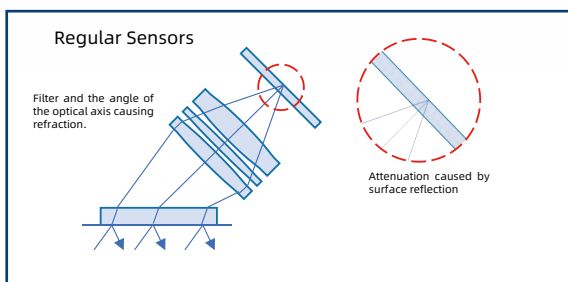


Basic Principle

The beam of light emitted by the laser shines on the target; the receiving lens focuses the diffusely reflected / reflected light from the surface of the target and focuses it on the photosensitive element.
When the distance to the target changes, the position of the light spot on the photosensitive element also changes.

Optimization of the receiving lens module

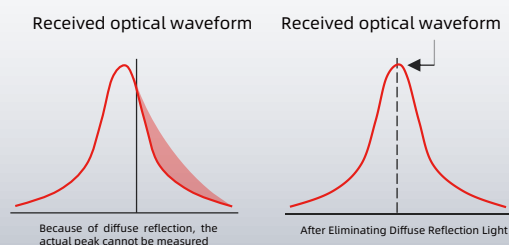
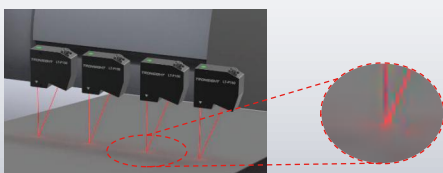
TronSight has improved the structure of the conventional laser triangulation sensor receiving lens module, which can maximize the avoidance of multiple spots caused by multiple reflections on the surface of the filter and the resulting misjudgment of the measurement position. At the same time, it improves the signal-to-noise ratio of the photoelectric data.



Semi-transparent object measurement algorithm

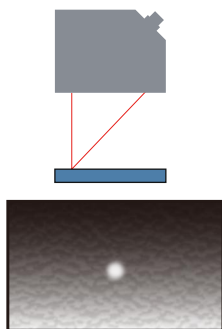
When the laser penetrates a semi-transparent object, it produces diffuse reflection from below the surface of the object, causing the received light waveform to slowly expand. The self-developed measurement algorithm for semi-transparent objects can eliminate the effect of the expanded waveform and detect the actual peak.

Semi-transparent object measurement algorithm



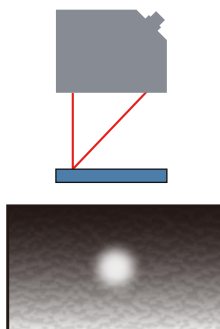
Light Spot Specification Description

Small Spot



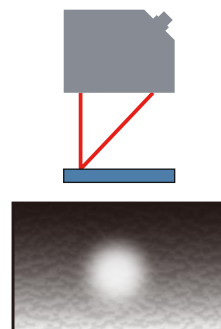
Correctly detect small targets through a minimum $\phi 18\ \mu\text{m}$ light spot, very suitable for shape measurement.

Wide Spot



By increasing the measurement spot size, it is more suitable for measuring targets with uneven surfaces, obtaining stable measurement values.

Ultra-wide Spot



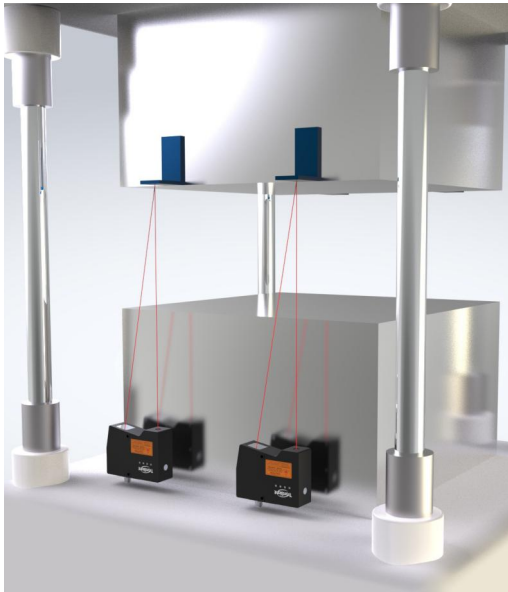
By further increasing the measurement spot size, it is suitable for accurate measurement of objects with greater surface roughness.

产品规格一览

Reference distance (mm)	TS-PD08	TS-PD15	TS-PD50	TS-P25	Reference distance (mm)	TS-P30	TS-P70	TS-P80	TS-P150
500					500				
400					400				
300					300				
200					200				
100					100				
0					0				
Repeatability	0.01 μm	0.05 μm	0.05 μm	0.01 μm	Repeatability	0.02 μm	0.2 μm	0.1 μm	0.25 μm
Linear error	< $\pm 0.5\ \mu\text{m}$	< $\pm 0.6\ \mu\text{m}$	< $\pm 0.6\ \mu\text{m}$	< $\pm 0.6\ \mu\text{m}$	Linear error	< $\pm 3\ \mu\text{m}$	< $\pm 20\ \mu\text{m}$	< $\pm 6\ \mu\text{m}$	< $\pm 16\ \mu\text{m}$

Reference distance (mm)	TS-P400	TS-P450	TS-P1000	TS-P1500	Reference distance (mm)	TS-P2250
2500					2500	
2000					2000	
1500					1500	
1000					1000	
500					500	
0					0	
Repeatability	1.5 μm	2 μm	12 μm	30 μm	Repeatability	50 μm
Linear error	< $\pm 60\ \mu\text{m}$	< $\pm 250\ \mu\text{m}$	< $\pm 500\ \mu\text{m}$	< $\pm 1000\ \mu\text{m}$	Linear error	< $\pm 650\ \mu\text{m}$

Application



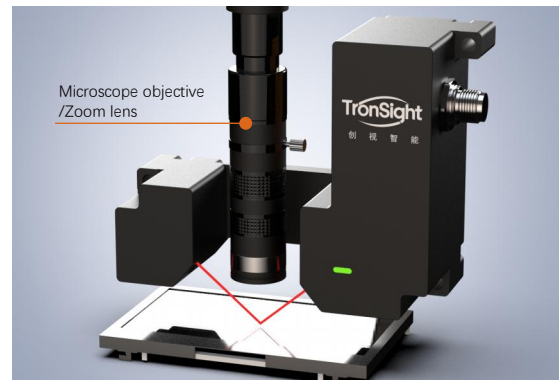
◆ Motion platform position measurement



◆ Online Thickness Measurement of Roller Pressed Plates



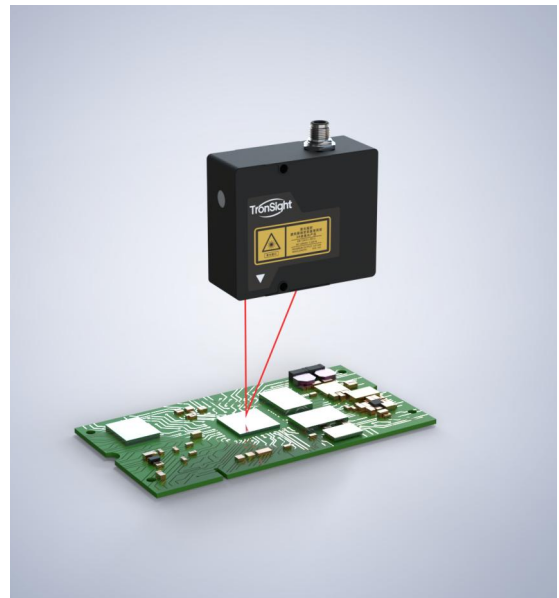
◆ Road surface smoothness measurement



◆ Coaxial height focus measurement



◆ High-frequency vibration measurement



◆ PCB component height, PCB board thickness measurement

Parameters

Sensor Head

Model	Reference ^{*1} Distance	Measurement Range	Spot Diameter	Static Noise ²	Static Noise ³	Linearity Error ^{*4}	Dimensions	Weight	Sampling Frequency	Light source ⁵		
PD08	8mm	±0.8 mm	Φ20μm	0.03μm	0.01μm	< ±0.5μm	82*115*38.5mm	213 g	Max. 160 kHz	655 nm Max. 4.9mW		
PD15	15mm	±1.0mm	Φ35μm	0.05μm	0.01μm	< ±0.6μm	102*137*55.5mm	475g				
PD50	50mm	±0.8 mm	Φ25μm	0.05μm	0.01μm	< ±0.6μm	74*205*110mm	725 g				
P25	25 mm	±1 mm	Φ18μm	0.05μm	0.01μm	< ±0.6μm	120*80*31mm	372 g	Max. 160 kHz	405 nm Max. 4.9 mW		
P30	30mm	±5mm	Φ35μm	0.15μm	0.02μm	< ±3μm	87*76*31mm	287 g				
P30W			About Φ35*400μm			< ±2μm						
P30U			About Φ35*1100μm	0.075μm							Max. 25kHz	
P70	70mm	-50mm +40mm	Φ70μm	1.3μm	0.3μm	< ±18μm	130*90*31mm	408 g	Max. 160 kHz	655 nm Max. 4.9 mW		
P70W			Φ70*500μm									
P80	80mm	±15mm	About Φ70μm	0.5μm	0.1μm	< ±6μm	93*78*37mm	359 g				
P80W			About Φ70*800μm									
P80U			About Φ70*2200μm	0.25μm					Max. 25kHz			
P150	150mm	±40mm	Φ110μm	1.2μm	0.25μm	< ±16μm	95*80*37 mm	374g	Max. 160 kHz		655 nm Max. 4.9 mW /660 nm Max.50mW	
P150W			About Φ110*1400μm									
P400	400mm	±100mm	Φ300μm	3μm	1.5μm	< ±60μm	115*85*37mm	438 g				
P400W			About Φ300*3400μm									
P450	450mm	±250mm	Φ320μm	8μm	2μm	< ±250μm	120*75*37mm	416 g				
P450W			About Φ320*4200μm									
P1000	1000mm	±500mm	Φ320μm	12μm	/	< ±500μm	180*85*40mm	785g		Max. 160 kHz		655 nm Max. 4.9 mW /660 nm Max.50mW
P1500	1500mm	±1000mm	Φ400μm	30μm	/	< ±1000μm	260*85*45mm	1,250g				
P2250	2250mm	±650mm	Φ700μm	50μm	/	< ±650μm	200*85*41mm	924 g	Max. 160 kHz		660 nm Max.50mW	
Customizable Model	8~2250mm	5~2500mm	Model related	20ppm of F.S.	Model related	Typical value ±0.05% of F.S.	Model related	Model related		Max. 160 kHz		Model related
Temperature Drift ⁶	0.01% of F.S./°C											
Industrial ^{*6} Interfaces	Ethernet, RS-485 serial port, analog signal output ^{*7} (Max. ±10V, 4-20mA)											
Control Software	Comes with TSLaserStudio control and measurement software and C++, C# software development kits											
Operating Mode	Operates independently without a controller. The probe can be configured as a master or slave, the master controls the slave to achieve functions such as synchronous thickness measurement, alternating exposure for interference resistance.											
Power Voltage	DC 9~36V, maximum allowable ±10% fluctuation											
Power Consumption	About 2.5W											
Degree of Protection	IP67											
Ambient Temperature	0 to +50°C											

*1 Calculation based on the center position of the measurement range;

*2 Measurement of standard white ceramic sample, 50kHz without averaging, taking the root mean square deviation (1 σ) of 65536 sets of measurement data; U series probes, 8kHz without averaging, taking the root mean square deviation (1 σ) of 65536 sets of measurement data;

*3 Measurement of standard white ceramic sample, 50kHz with 1024 averaging times, taking the root mean square deviation (1 σ) of 65536 sets of measurement data; U series probes, 8kHz with 1024 averaging times, taking the root mean square deviation (1 σ) of 65536 sets of measurement data;

*4 Calibration and verification using nanometer-level high-precision laser interferometer;

*5 Laser power can be customized according to different application requirements, some models provide 405nm blue light version;

*6 The probe can independently provide voltage, current, and RS485 output;

*7 Optional analog voltage/current output module.

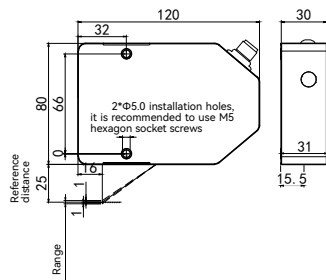
Laser Triangulation
Displacement Sensor

Spectral Confocal
Displacement Sensor

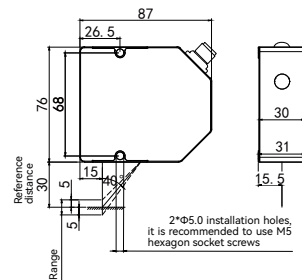
Interferometric
Thickness Sensor

Dimension Figure

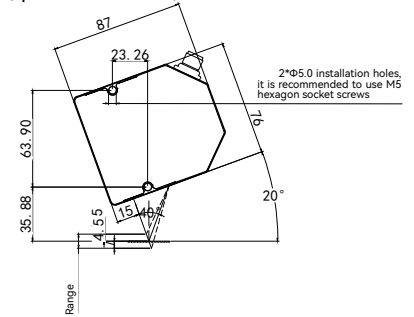
TS-P25



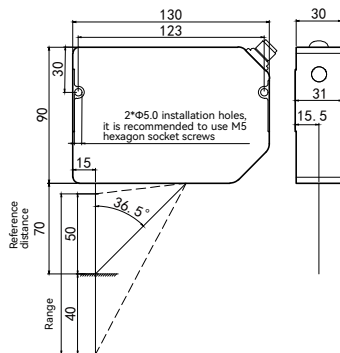
TS-P30



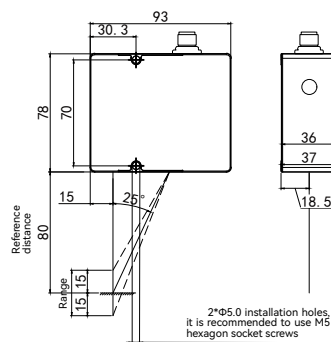
TS-P30 Slanting Installation
(Specular reflection mode)



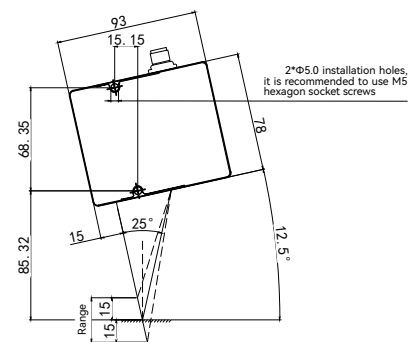
TS-P70



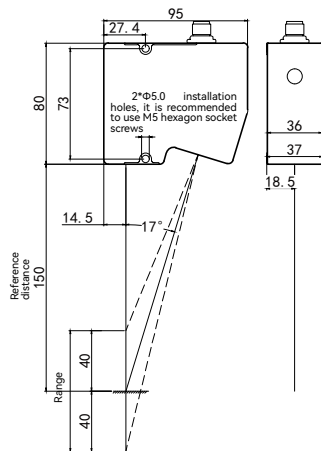
TS-P80



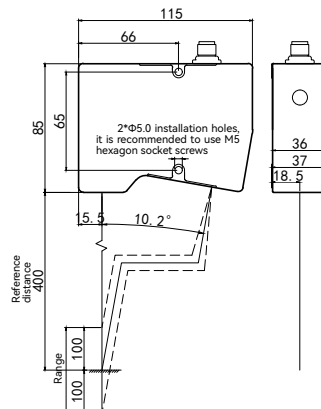
TS-P80 Slanting Installation
(Specular reflection mode)



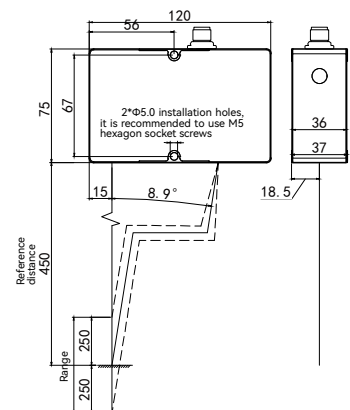
TS-P150



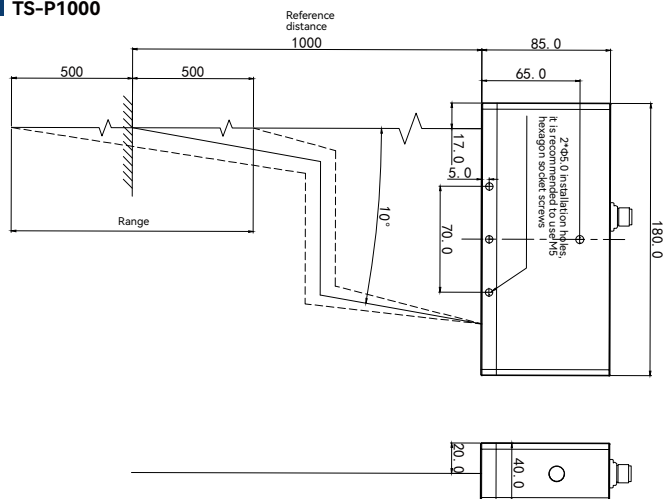
TS-P400



TS-P450

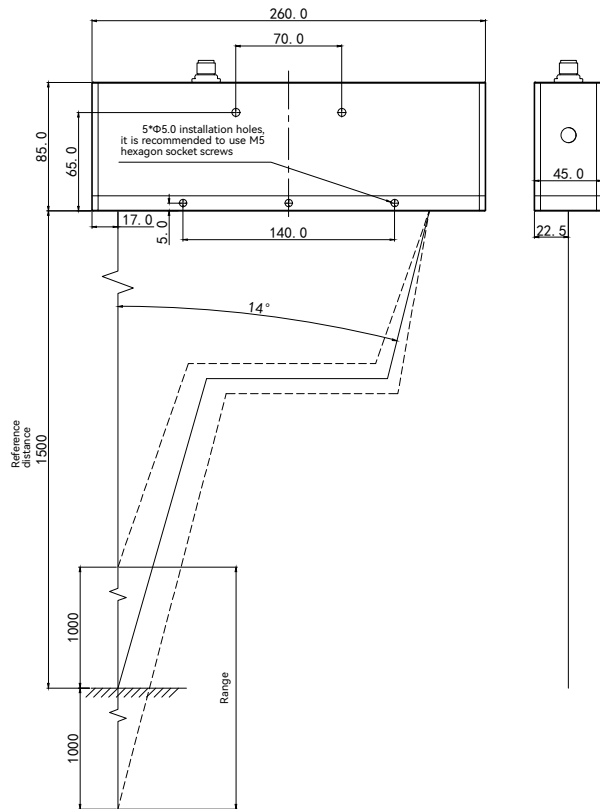


TS-P1000

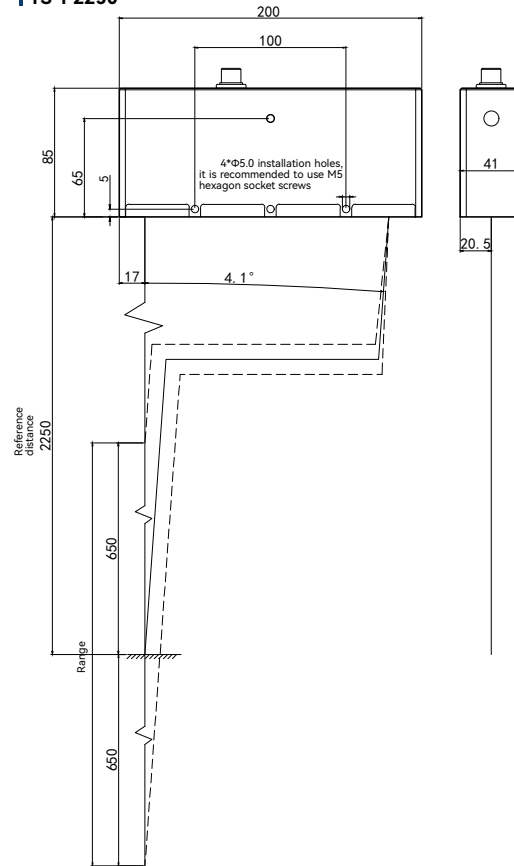


Dimension Figure

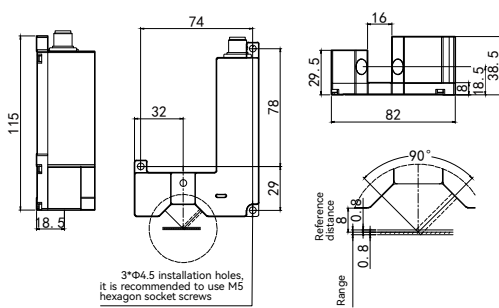
TS-P1500



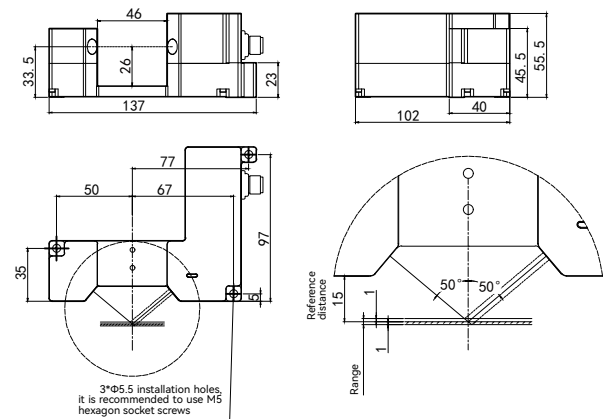
TS-P2250



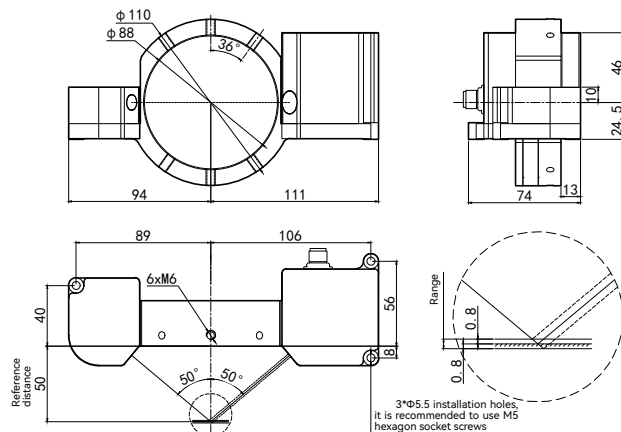
TS-PD08



TS-PD15

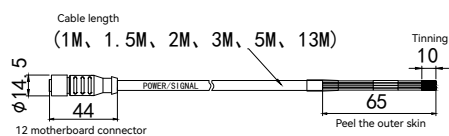


TS-PD50

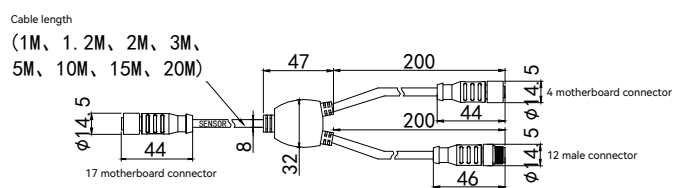


Component Drawings

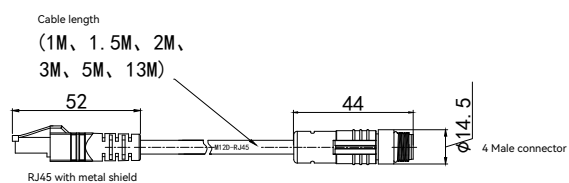
M12-12 Core Shielded Female Connector Harness



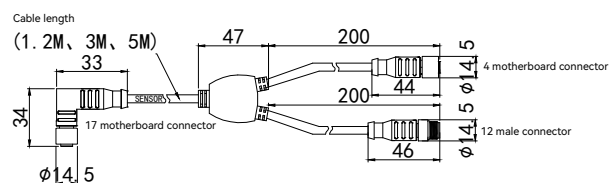
Y-type Splitter



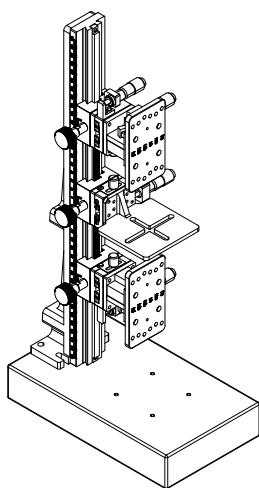
M12d Type Adapter To RJ45 Connector



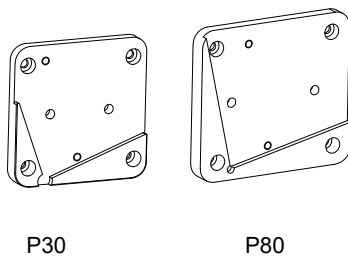
90° Y-type Splitter



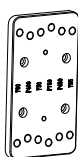
Vertical Jig and Fixture



Slanting Installation Board



Connection Board





| TS-C Series | Spectral Confocal Displacement Sensor

3
nm

Ultra-high
Repeatability

± 0.02
% of F.S

Ultra-high
Linearity

Max **30**
kHz

Ultra-fast
Sampling Rate

$\pm 60^\circ$

Ultra-large
Measurement Angle



◆ Why choose TronSight?



Minimal Measurement
Dead Zone



High Interference
Immunity



Sub-micron
Measurement Precision



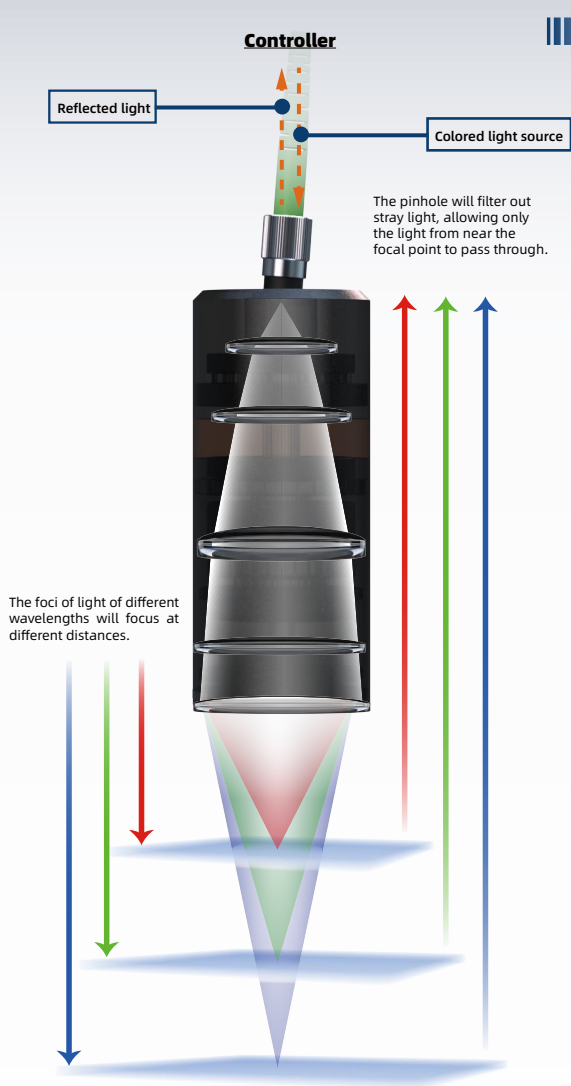
Ultra-Smooth Mirror
Surface Measurement



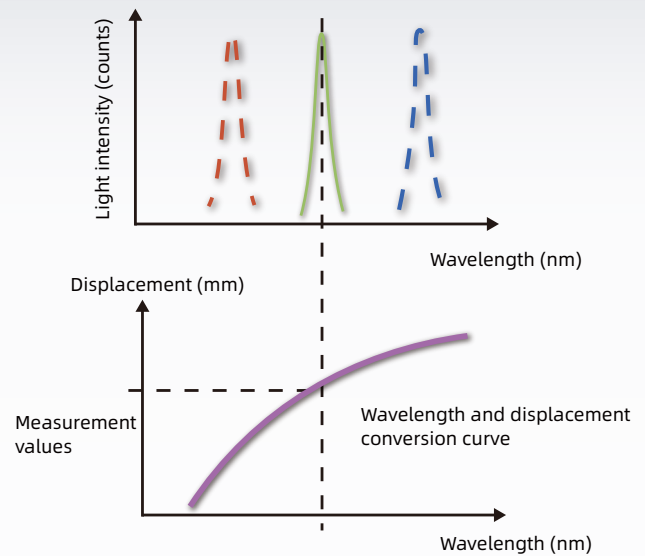
Multi-layer Transparent
Material Thickness
Measurement



Axial and Radial Light
Emission Measurement



Spectral Confocal Receives Spectral Signals



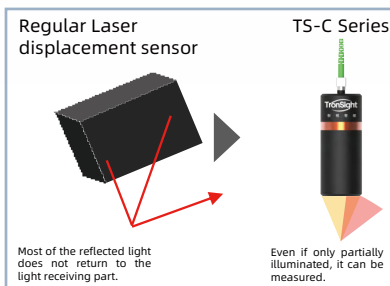
Basic Principle

When white point light source passes through the dispersive confocal probe and illuminates the target, different wavelength components of the light source form a longitudinal distribution; the light spot on the target returns through the coaxial optical path and then passes through a pinhole aperture, connecting to the spectrometer. When the distance to the target changes, the wavelength of the focused light also changes, resulting in different spectral distributions in the spectrometer.

Accurately measure objects with different structural features

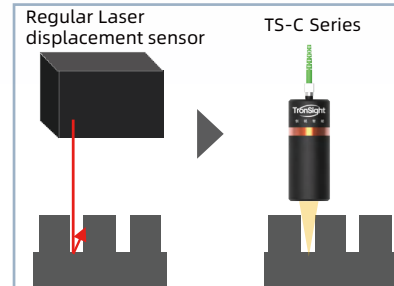
Achieving high-precision measurement of transparent curved surfaces.

Even with only partial reflection, high-precision measurements can be achieved.



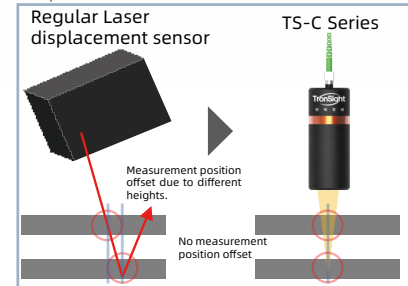
Measure pits and steps without blind spots.

Using a confocal coaxial method, it can measure without affecting the installation direction and movement direction of the probe.



Accurate measurement of transparent and reflective objects.

Even if the measurement height of transparent or mirrored objects changes, it can accurately measure to the same measurement point without worrying about positional deviation.



Multiple input and output methods

The standard configuration of the controller includes six types of I/O channels: USB, RS485, Ethernet, analog, digital, and level/encoder trigger. It supports functions such as PC-based upper computer software control, PLC bus control, multi-channel data acquisition by data acquisition card, and external encoder synchronous trigger, which can meet various usage requirements.

USB

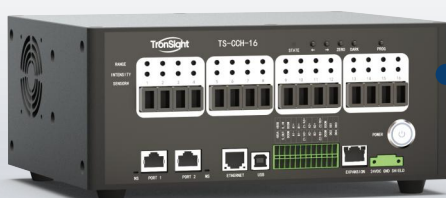
RS485

Ethernet

Analog

Digital

Leveler/Encoder Trigger



USB, Ethernet

PC

RS485, Ethernet

PLC

Analog, Digital

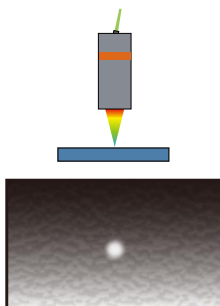
Data acquisition card

Leveler/Encoder Trigger

Encoder

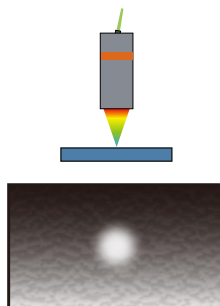
Light Spot Specification Description

Small spot



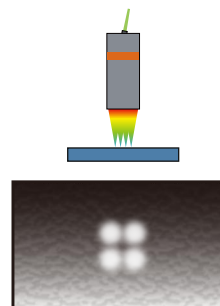
Detecting small targets accurately with a minimum spot size of $\Phi 1.7\mu\text{m}$ is ideal for shape measurement.

Wide spot



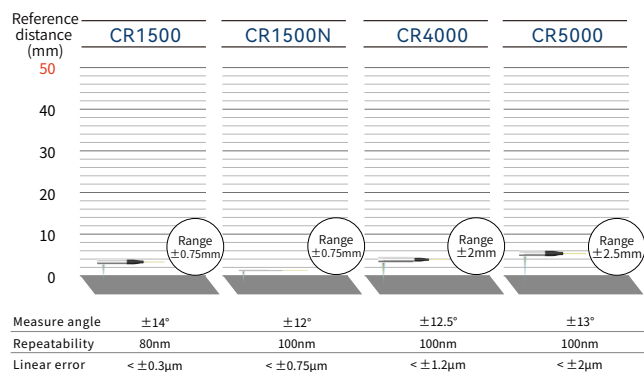
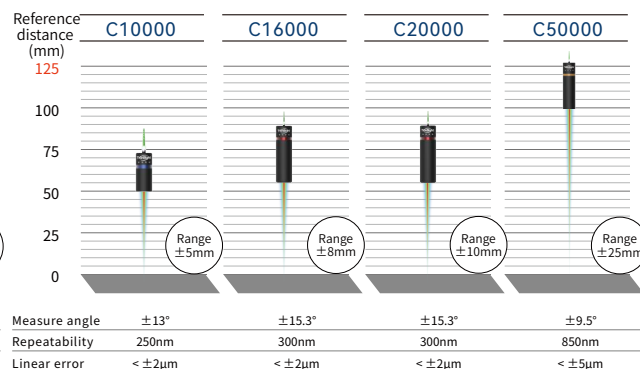
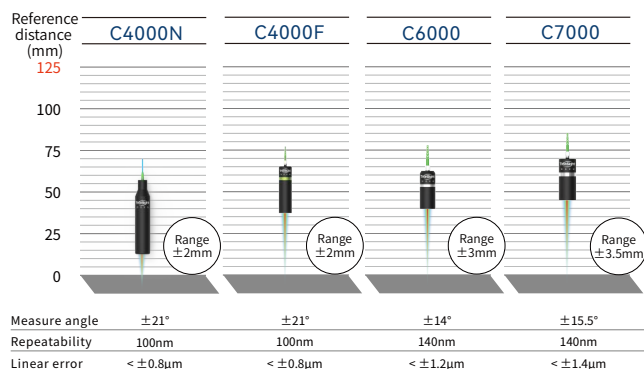
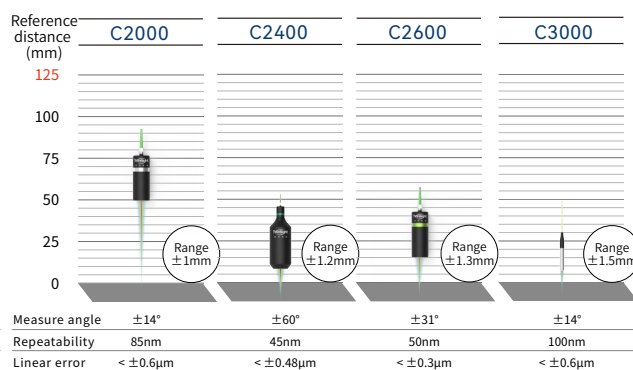
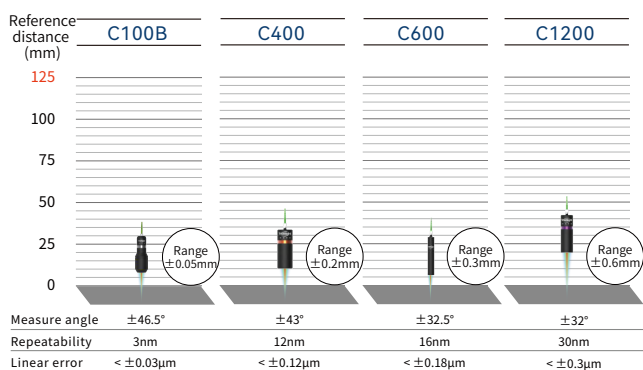
By increasing the measurement spot size, it is more suitable for measuring uneven surfaces, obtaining stable measurement values.

Ultra-wide spot



Measuring with four independent spots and performing numerical calculations can eliminate the effects of surface irregularities and roughness.

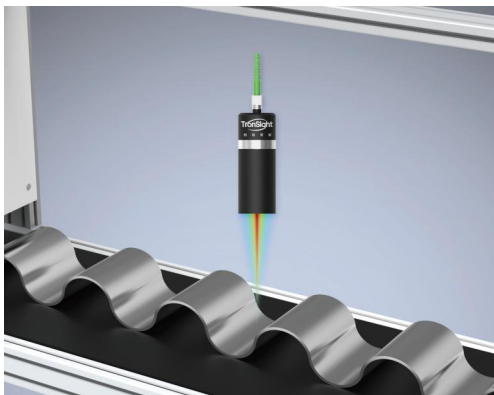
Product Specifications



Application



◆ Measurement of the R-curve angle of the mobile phone screen



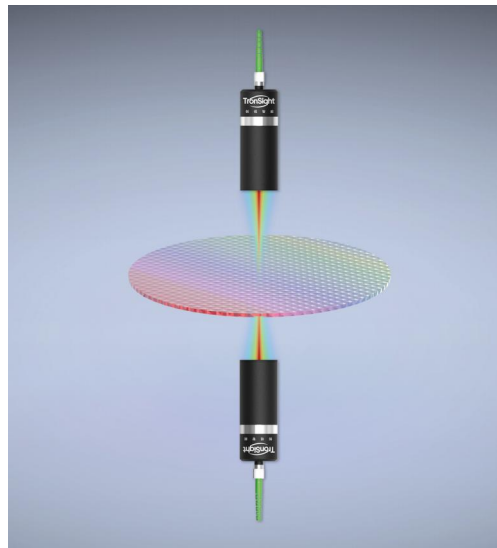
◆ Metal workpiece profile measurement



◆ Flatness measurement of structural components



◆ PCB component height difference measurement



◆ Wafer Mapping Thickness Measurement



◆ Flatness measurement of structural components

Parameters

Sensor Head

Model	Reference Distance ^{*1}	Measurement Range	Spot Diameter ^{*2}	Spot Diameter ^{*3}	Static Noise ^{*4}	Linearity Error ^{*5}	Outer Diameter *Length	Weight	Minimum Measurable Thickness	Temperature Characteristics	Degree of Protection	
C100B ^{*8}	8mm	±0.05mm	±46.5°	Φ2.7μm/5.4μm/43.2μm	3nm	< ±0.03μm	φ40×111.5mm	256g	5%off.F.S.	<0.03%F.S./°C	IP40	
C400	10mm	±0.2mm	±43°	Φ7μm/14μm/112μm	12nm	< ±0.12μm	φ40×99.4mm	186g				
C600	6.5mm	±0.3mm	±32.5°	Φ8μm/16μm/128μm	16nm	< ±0.18μm	φ20×110mm	73g				
C1200	20mm	±0.6mm	±32°	Φ9.5μm/19μm/152μm	30nm	< ±0.3μm	φ36×106.3mm	182g				
C2000	50mm	±1mm	±14°	Φ20μm/40μm/320μm	85nm	< ±0.6μm	φ34×90.7mm	162g	10%off.F.S.	~0.1%F.S./°C		
C2400	9mm	±1.2mm	±60°	Φ5.5μm/11μm/88μm	45nm	< ±0.48μm	φ94×267.5mm	2350g	5%off.F.S.	<0.03%F.S./°C		
C2600	15mm	±1.3mm	±31°	Φ9μm/18μm/144μm	50nm	< ±0.3μm	φ36×97.9mm	228g	5%off.F.S.			
C2600H	15mm	±1.3mm	±31°	Φ9μm/18μm/144μm	50nm	< ±0.3μm	φ36×97.9mm	228g				
C3000	7mm	±1.5mm	±12.5°	Φ20μm/40μm/320μm	100nm	< ±0.6μm	φ8×38.7mm	23g ^{*7}	10%off.F.S.	~0.05%F.S./°C	IP67	
C4000N	14.5mm	±2mm	±21°	Φ12μm/24μm/192μm	100nm	< ±0.8μm	φ32×158.8mm	238g	5%off.F.S.	<0.03%F.S./°C	IP40	
C4000F	38mm	±2mm	±21°	Φ16μm/32μm/256μm	100nm	< ±0.8μm	φ36×126.1mm	226g		~0.05%F.S./°C		
C6000	40mm	±3mm	±14°	Φ22μm/44μm/352μm	140nm	< ±1.2μm	φ30×71mm	112g				
C7000	45mm	±3.5mm	±15.5°	Φ20μm/40μm/320μm	140nm	< ±1.4μm	φ36×84.2mm	200g		<0.03%F.S./°C		
C7000L	47mm	±3.5mm	±21°	Φ16μm/32μm/256μm	140nm	< ±1.4μm	φ52×207mm	784g				
C7000S	70mm	±3.5mm	±10°	Φ25μm/50μm/400μm	200nm	< ±1.4μm	φ30×84.2mm	130g				
C10000	50mm	±5mm	±13°	Φ20μm/40μm/320μm	250nm	< ±2μm	φ36×84mm	203g				
C16000	55mm	±8mm	±15.3°	Φ15μm/30μm/240μm	300nm	< ±2μm	φ60×211.1mm	1180g				
C20000	55mm	±10mm	±15.3°	Φ15μm/30μm/240μm	300nm	< ±2μm						
C50000	100mm	±25mm	±9.5°	Φ25μm/50μm/400μm	850nm	< ±5μm	φ60×217.3mm	1154g				
CR1500 ^{*6}	Axial: 3.92mm Radial:5.75mm	±0.75mm	±14°	Φ20μm	80nm	< ±0.3μm	φ8×47.7mm	23g ^{*7}	10%off.F.S.			
CR1500N	Axial: 1.7mm Radial:3mm											
CR4000	Axial: 4.7mm Radial:8mm ^{*8}	±2mm	±12.5°	Φ20μm	100nm	< ±1.2μm	φ8×39mm	24g ^{*7}				
CR5000 ^{*8}	Axial: 6.75mm Radial:12mm											
Customizable Model	1~500mm	0.1~50mm	±5°~60°	1~100μm	4~2000nm	Typical value ±0.02%off.F.S.	Model related	Model related	Model related	Model related		

*1 Calculated from the center position of the measurement range;

*2 Tilt test using standard flat mirror at 1kHz sampling rate;

*3 Measurement of sharp glass edges, verified with a sub-micron positioning accuracy motion platform and laser interferometer as the displacement reference, the spot diameter values correspond to the diameters of small spot/large spot/four-spot pattern;

*4 Measurement of standard silver-coated mirror, 1kHz without averaging, root mean square deviation of 10,000 continuous data sets;

*5 Calibration verification using high-precision nanoscale laser interferometer;

*6 Models starting with CR have a 90° side-emitting version suitable for deep hole, inner wall, and side feature measurements;

*7 This probe model includes a 3m tail cable, and the weight in the table includes the weight of the cable;

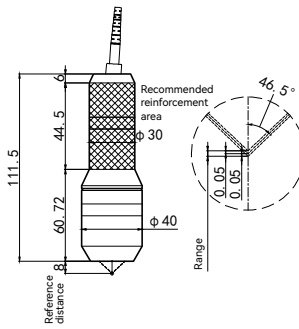
*8 This model is a new product, actual parameters may vary slightly, refer to the contract.

Controller

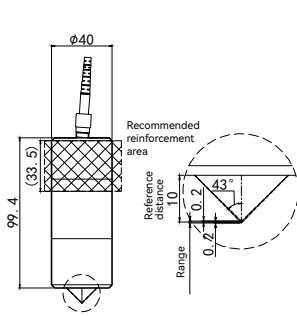
Model	TS-CCS	TS-CCD	TS-CCF	TS-CCH
Sensor Head Connection Capacity	1	2	4	4,8,16
Sampling Frequency	Single Channel Mode: Max. 10 kHz; Dual Channel Mode: Max. 5 kHz; Quad Channel Mode: Max. 2.5 kHz			Single Channel Mode: Max. 20 kHz; Dual Channel Mode: Max. 18 kHz; Quad Channel Mode: Max. 12.5 kHz; Eight Channel Mode: Max. 8 kHz; Sixteen Channel Mode: Max. 4 kHz (The above are preliminary evaluation results, specifications may change at the time of final release)
Input port	Trigger Signal Input	AB / ABZ encoder input, configurable for trigger		
	Trigger Signal Input	Pulse / Level trigger		
Output port	Digital Signal Output	Alarm output, comparator output (configurable as comparator output or data invalid warning)		
	Analog Signal Output	Linear ±10 V analog voltage output / 4~20 mA analog current output (optional module)		
Industrial Interface	Ethernet Interface	100BASE-TX		1000/100Mbps
	USB Interface	Complies with USB2.0 Full-speed standard		USB2.0 High-speed
	RS485	Modbus protocol, 19200~115200 baud rate		
	EtherCAT	\		Optional configuration
Control and Measurement Software	Host Computer Software	TSConfocalStudio Control and Measurement Software		
	Secondary Development Package	C++ and C# Software Development Package		
Rated Power	Supply Voltage	24 VDC		
	Current Consumption	About 0.4 A		About 0.5A (when only one channel is enabled), about 4A (when 16 channels are enabled), it is recommended to configure a power supply of 24V 6A or above
Environmental Tolerance	Operating Temperature	0 to +50°C		
	Relative Humidity	20 to 85% RH (no condensation)		
Weight		About 2,000g		About 2,800g (varies depending on the number of channels and configuration)

Dimension Figure

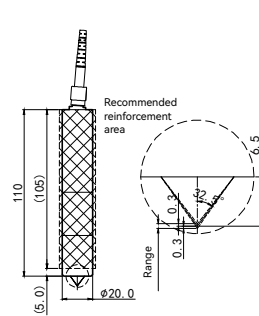
TS-C100



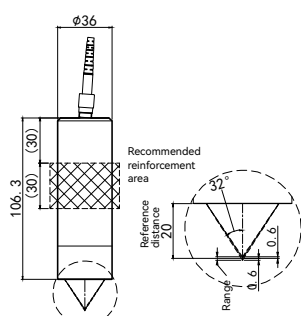
TS-C400



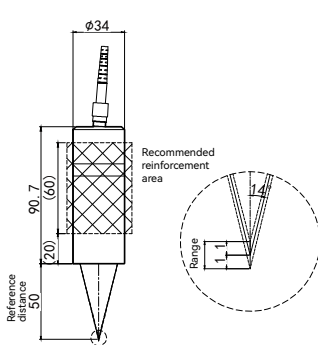
TS-C600



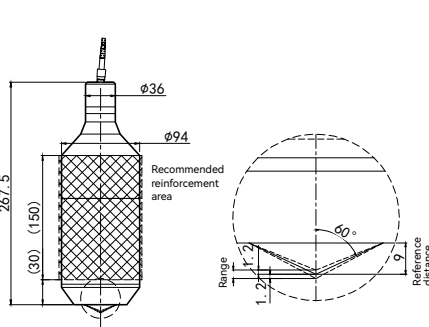
TS-C1200



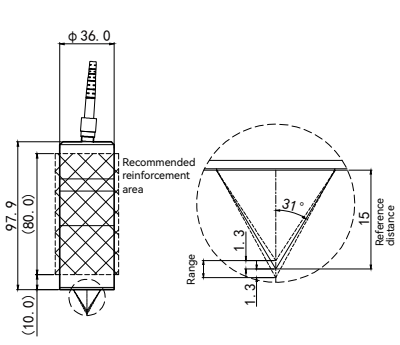
TS-C2000



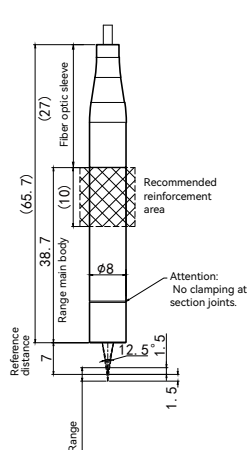
TS-C2400



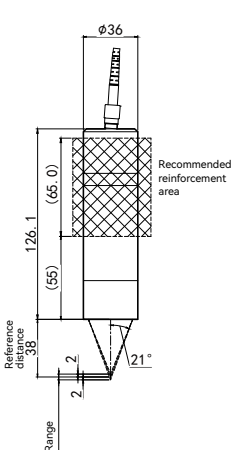
TS-C2600



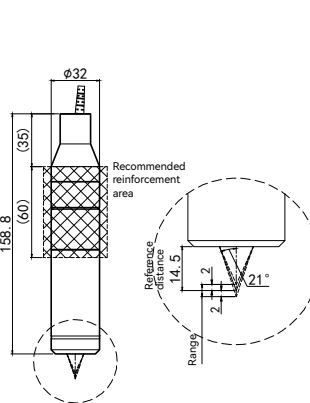
TS-C3000



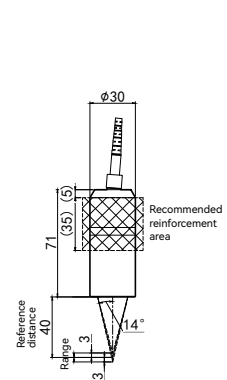
TS-C4000F



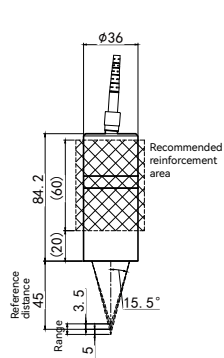
TS-C4000N



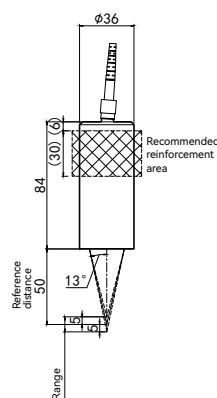
TS-C6000



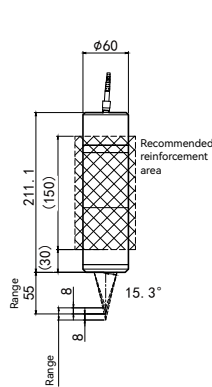
TS-C7000



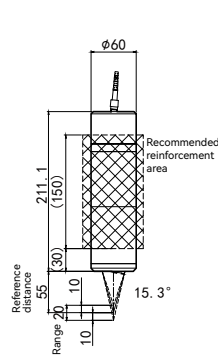
TS-C10000



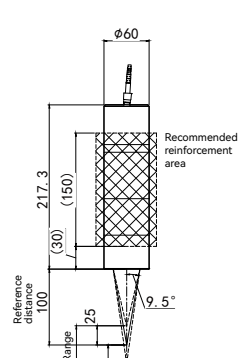
TS-C16000



TS-C20000

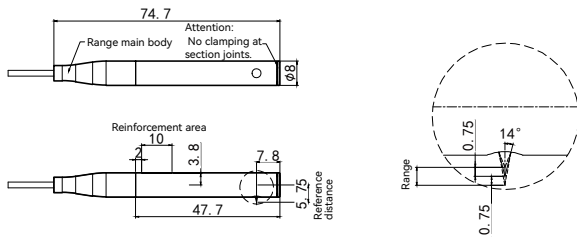


TS-C50000

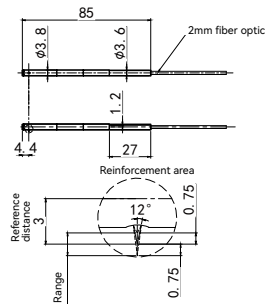


Dimension Figure

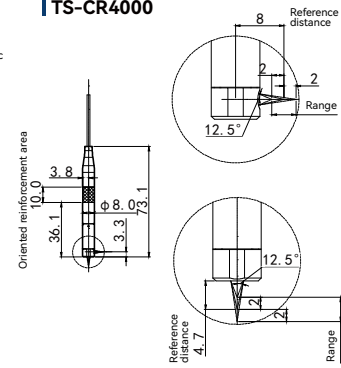
TS-CR1500



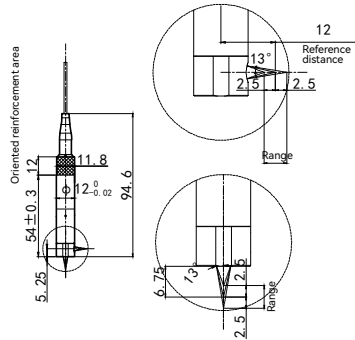
TS-CR1500N



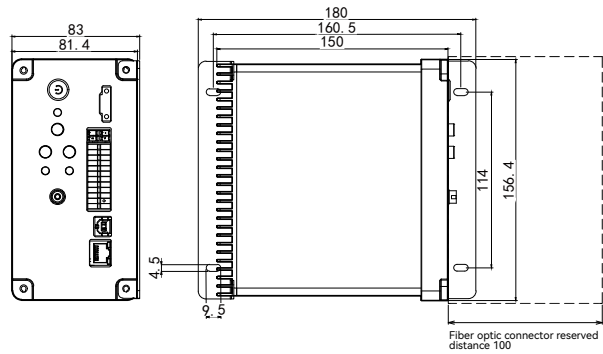
TS-CR4000



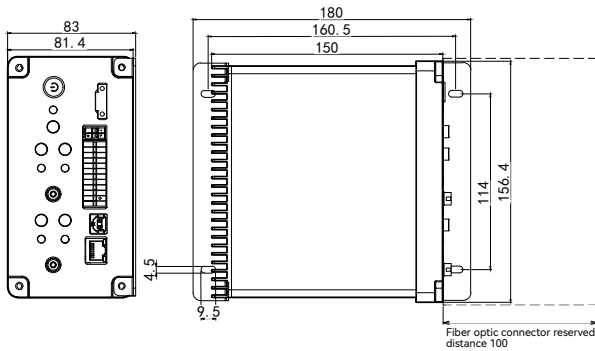
TS-CR5000



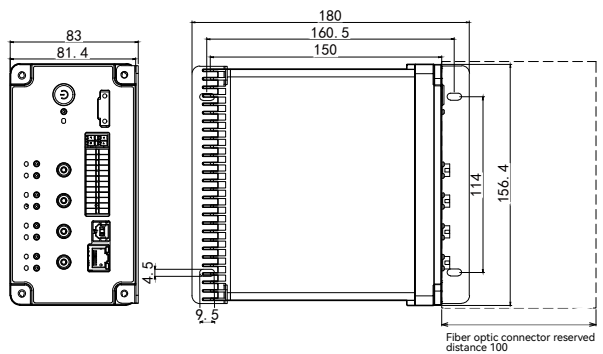
TS-CCS(With Footpad)



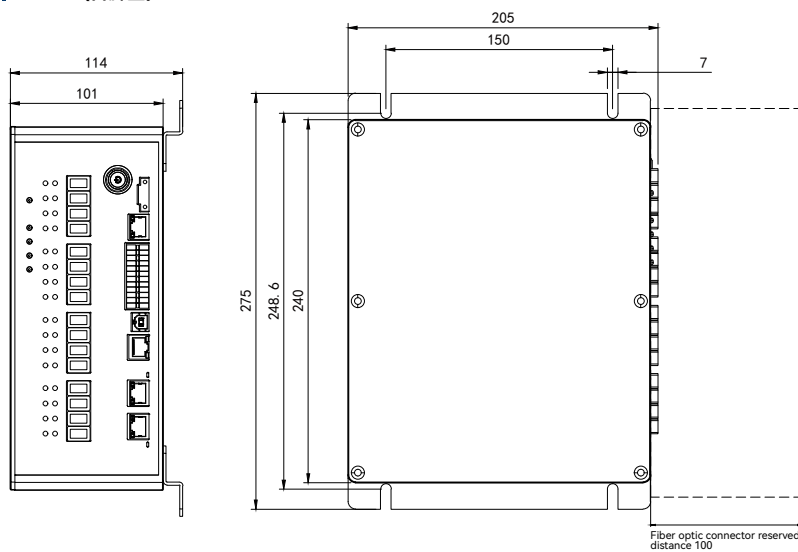
TS-CCD(With Footpad)



TS-CCF(With Footpad)

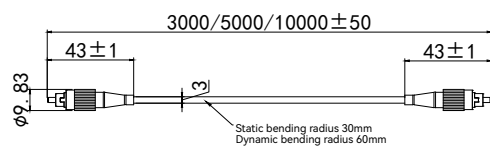


TS-CCH(含脚垫)

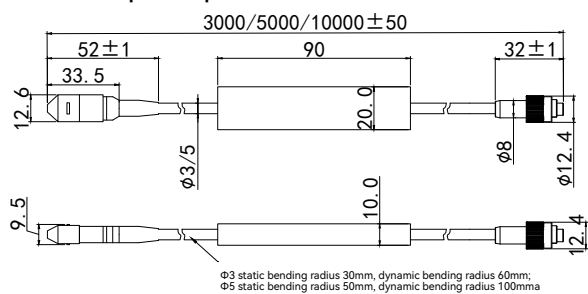


Component Drawings

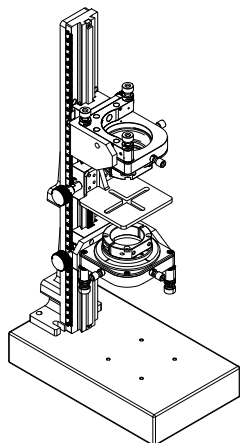
FC Fiber Optic Jumper



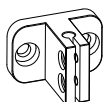
MPO Fiber Optic Jumper



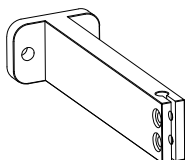
Vertical Jig and Fixture



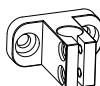
Clamp Piece



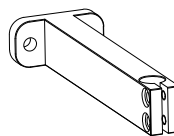
D3.8L15



D3.8L80



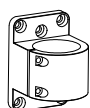
D8L15



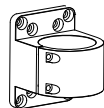
D8L80



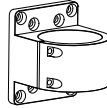
D20



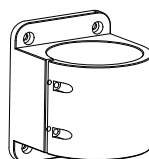
D30



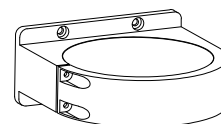
D36



D40



D60



D94



| TS-I Series | Interferometric Thickness Sensors

1
nm

Ultra-high
Repeatability

± 20
nm

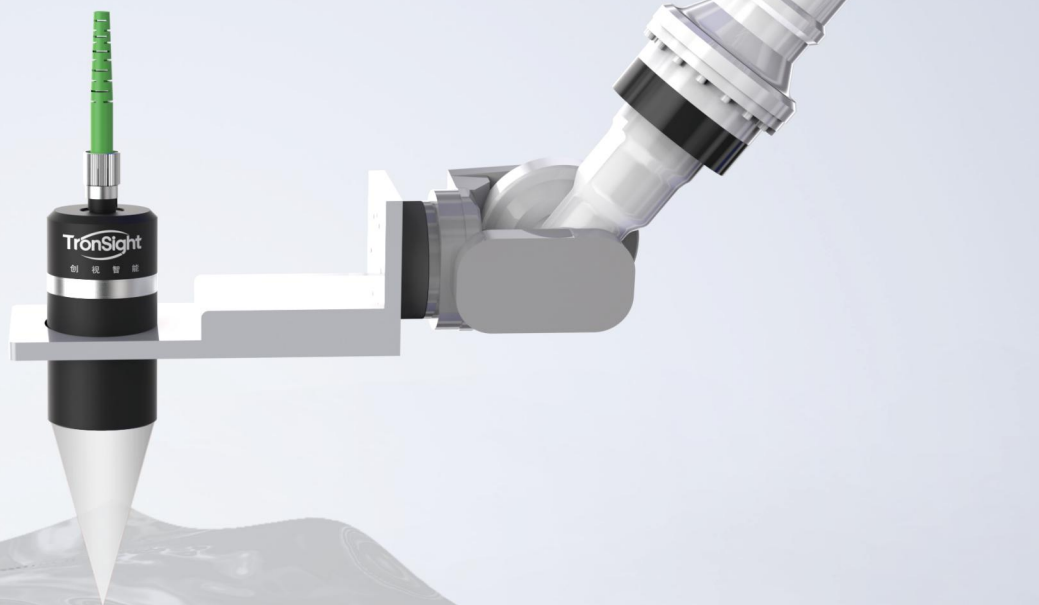
Ultra-high
Linearity

Max **10**
kHz

Ultra-fast
Sampling Rate

1~2500
 μm

Ultra-wide Thickness
Measurement Range



◆ Why choose TronSight?



Minimal Measurement
Dead Zone



High Interference
Immunity



Nanometer-level
Measurement Accuracy



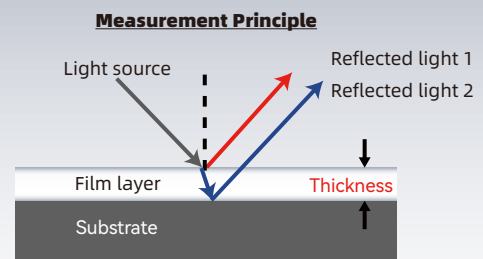
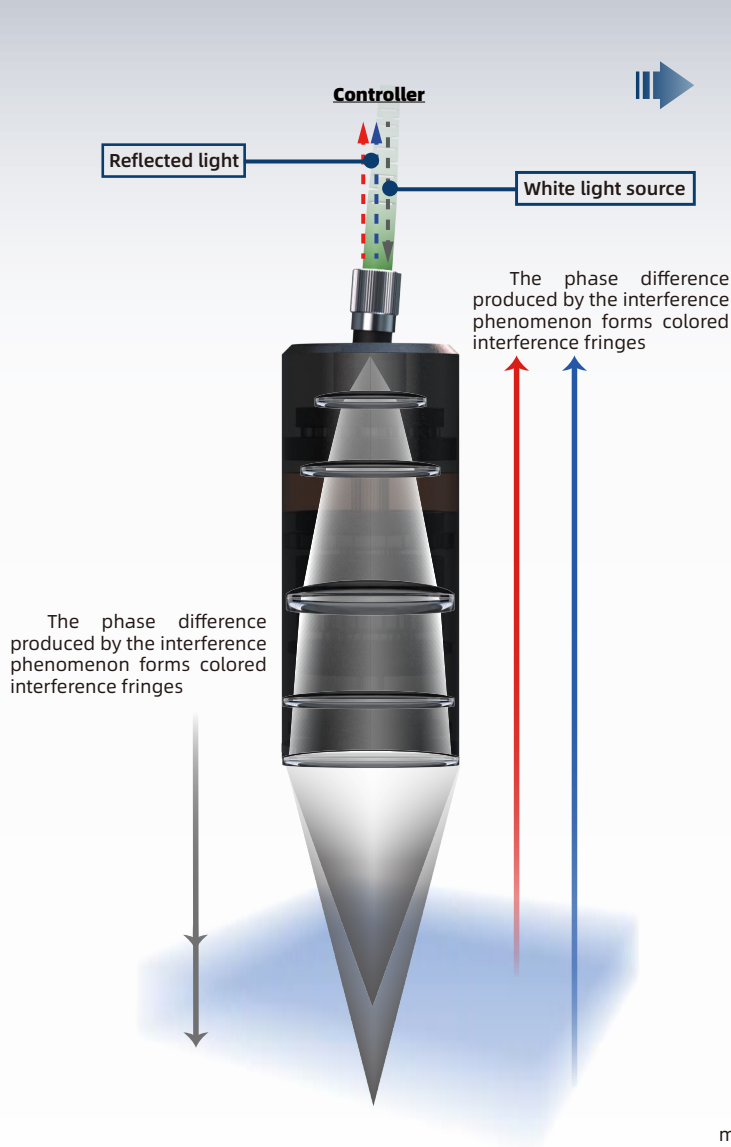
Non-contact
Measurement



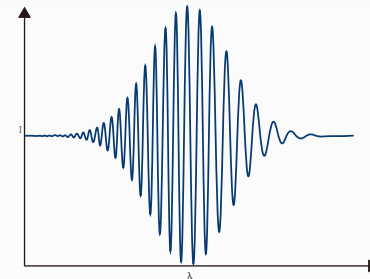
Film And Coating
Thickness Measurement



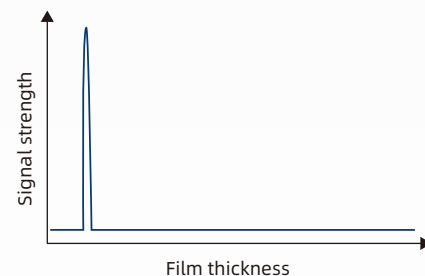
Wide Range
Working Distance



White Light Interference Receives Spectral Signals



Interference Signal Analysis And Thickness Mapping

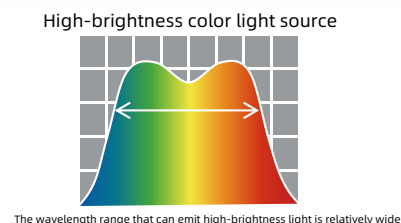
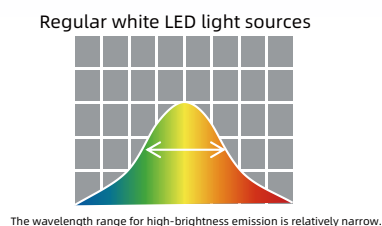


Basic Principle

The white point light spectrum passes through the interferometric probe and illuminates the surface of the sample. The reflected light from the upper and lower surfaces of the sample is simultaneously received by the interferometric probe. The phase difference between the two reflected beams is related to the film thickness, thus allowing the calculation of the film thickness value by analyzing the interference fringes.

High-brightness color laser light source

Blue laser light is shone on a phosphor that simultaneously emits red and green light, generating multi-color light. Compared to ordinary white LED light sources, it can achieve stable high-brightness emission over a wider range of wavelengths.



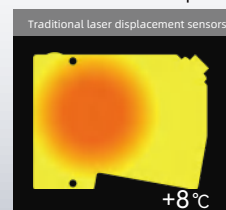
Zero heat-generating probe design

Traditional laser displacement sensors can cause deformation of the fixture and optical axis misalignment due to their own emissions, leading to measurement errors. The probe of this sensor is designed with only lens structures internally. Since there are no electronic components, it does not generate heat, thus preventing the deformation of the fixture where the probe is installed. This design allows for ideal high-precision measurements.

Before the probe heats up After the probe heats up



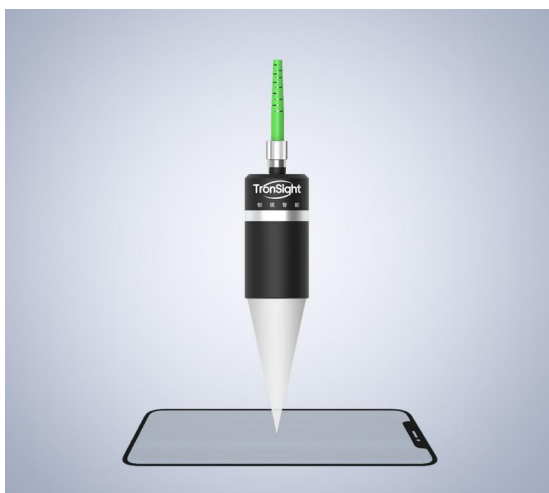
Traditional laser displacement sensors



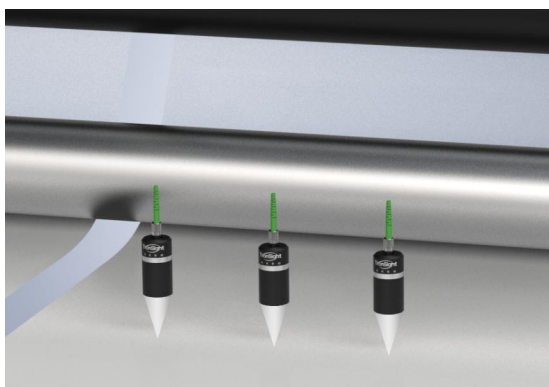
Product Specifications

Reference distance (mm)	T50	T10-UV-VIS
125		
100		
75		
50		
25		
0		
	Range $\pm 2\text{mm}$	Recommended installation distance 5-10mm
Measure angle	$\pm 3^\circ$	$\pm 10^\circ$
Repeatability	1nm	1nm
Linear error	$< \pm 20\text{nm}$	$< \pm 20\text{nm}$

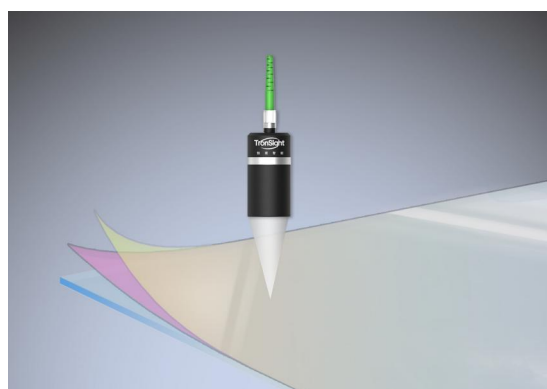
Application



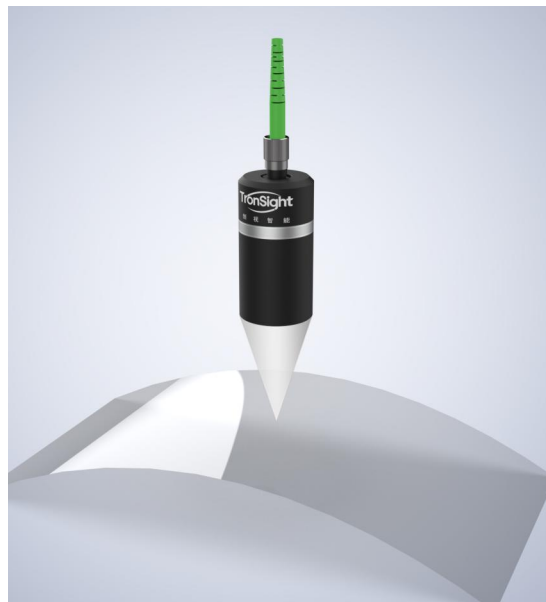
◆ Thickness Measurement of ITO Film for Touch Screens



◆ Thickness Measurement of Lithium-ion Battery Separator



◆ Thickness Measurement of Multilayer PET Films



◆ Thickness Measurement of Ultra-Thin Flexible Glass (UTG)

Parameters

Sensor Head

Series	IVS-100	IVS-100W	IVS-50	IVS-50W
Controller model	IVCS-100	IVCS-100W	IVCS-50	IVCS-50W
Adapt probe model	IVP-T50	IVP-T10-UV-VIS	IVP-T50	IVP-T10-UV-VIS
Reference distance ^{*1}	50mm	Non-focused probe	50mm	Non-focused probe
Recommended measurement range	±2mm	The recommended installation distance is 5-10mm	±2mm	The recommended installation distance is 5-10mm
Measurement Angle ^{*2}	±3°	±10°	±3°	±10°
Spot type ^{*3}	Focus light dots, Φ100μm	Dispersive spot, spot diameter of about 4mm at a mounting distance of 10mm	Focus light dots, Φ100μm	Dispersive spot, spot diameter of about 4mm at a mounting distance of 10mm
Static noise ^{*4}	1nm	1nm	1nm	1nm
Linear error ^{*5}	<±20nm	<±20nm	<±20nm	<±20nm
External diameter*length	Φ30*58mm	Φ6.35*65mm	Φ30*58mm	Φ6.35*65mm
Probe weight	90g	\	90g	\
Degree of protection	IP40	\	IP40	\
Sensor Head Connection Capacity	1	1	1	1
Sampling frequency	Max.10 kHz			
Scope of thickness measurement	About 2 μm~100 μm (when the refractive index is 1.5)		About 1 μm~50 μm (when the refractive index is 1.5)	
Input port	Encoder input	The AB / ABZ encoder input, which can be configured for triggering		The AB / ABZ encoder input, which can be configured for triggering
	Trigger signal input	Pulse / level trigger		Pulse / level trigger
Output port	Digital signal output	Alert output, comparator output		Alert output, comparator output
	Analog signal output	Linear ± 10 V analog voltage output / 4-20 mA analog current output (optional module)		Linear ± 10 V analog voltage output / 4-20 mA analog current output (optional module)
Industrial interface	Ethernet Interface	100BASE-TX		100BASE-TX
	USB joggle	Meet the USB2.0 Full-speed criteria		Meet the USB2.0 Full-speed criteria
	The RS485 interface	Modbus Protocol, 19200 to 115200 baud rates		Modbus Protocol, 19200 to 115200 baud rates
TT&C software	Upcomputer software	TSConfocalStudio Measurement and control software		TSConfocalStudio Measurement and control software
	Secondary development package	C++ and C# software development package		C + + and C # software development package
Rated power	supply voltage	24 VDC±10%		24 VDC±10%
	current consumption	About 0.4 A		About 0.4 A
Environmental resistance	working temperature	From 0 to + 50°C		From 0 to + 50°C
	relative humidity	20 to 85% RH (no condensation)		20 to 85% RH (no condensation)
Controller weight	About 2,000g		About 2,000g	

*1 Focus position, where the return signal from the sensor is strongest;

*2 Use a standard flat mirror for tilt testing at a 1kHz sampling rate;

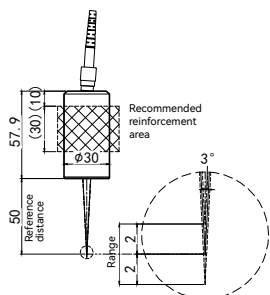
*3 Measure sharp glass edges using a sub-micron positioning accuracy motion platform with a laser interferometer as the displacement reference for verification;

*4 Measure standard film thickness samples, collect 10,000 sets of thickness data continuously at 1kHz without averaging to calculate the root mean square deviation;

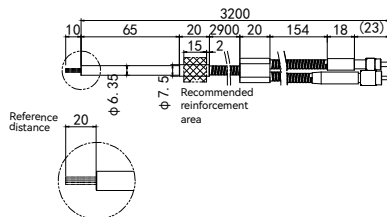
*5 Theoretical value

Dimension Figure

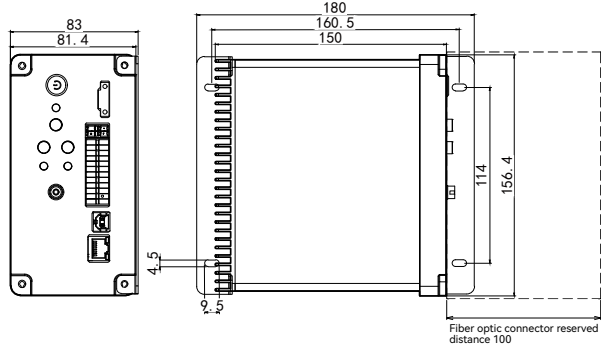
IVP-T50



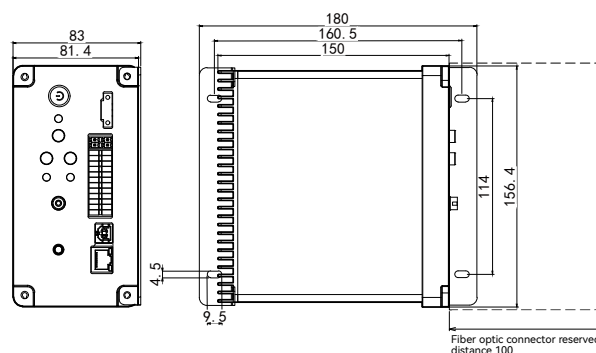
IVP-T10-UV-VIS



TS-IVS50/TS-IVS100(With Footpad)

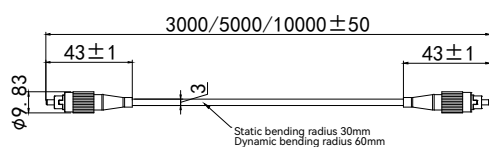


TS-IVS100W(With Footpad)



Component Drawings

FC Fiber Optic Jumper





China's Leading Provider of High-End Photoelectric Displacement Sensors



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